Title: Basic FIB operator training

Training duration: 3 days

Training cost: Groups of 1 – 5 trainees, US$3600 per group

Background required: Introduction to Focused Particle Beam Technology, or equivalent knowledge

Student Objective: Know and understand major components of FIB system, independently load sample, obtain image, perform basic milling and deposition operations. Independently perform daily maintenance and basic calibrations

Equipment: Micrion 2000, 2500, 9000, 9100, 986, 986FC, Vectra 986(+), VectraVision,

Syllabus: Available online: www.partbeamsystech.com/training